



Express Mail Label No. EV755076100US
Docket No. 51899

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Cameron et al.

SERIAL NO. 10/822,225 GROUP: 2891

FILED: April 9, 2004 EXAMINER: B. Smith

FOR: METHODS, PHOTORESISTS AND SUBSTRATES FOR ION-IMPLANT LITHOGRAPHY (as amended)

Mail Stop: Amendments
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Applicants are in receipt of the Office Action dated September 25, 2006.

An amendment to the specification appears on page 2 of this paper.

A listing of pending claims begins on page 3 of this paper.

Remarks begin on page 9 of this paper.

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Please amend the title to read as follows:

--METHODS, PHOTORESISTS AND SUBSTRATES FOR ION-IMPLANT
LITHOGRAPHY--